

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Mail Stop Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF OCTOBER 17, 2005

Please amend the above-identified application as follows:

The currently pending are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 13 of this paper.

Remarks/Arguments begin on page 14 of this paper.

An **Appendix** including amended drawing figures is attached following page 16 of this paper.